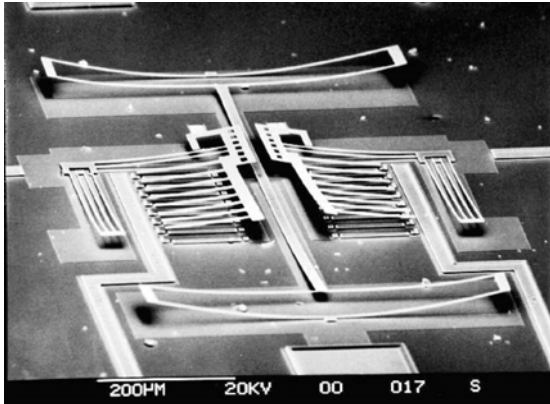


Vertical Stress Gradients

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- Variation of residual stress in the direction of film growth
- Can warp released structures in z-direction



200µm 20KV 00 017 S

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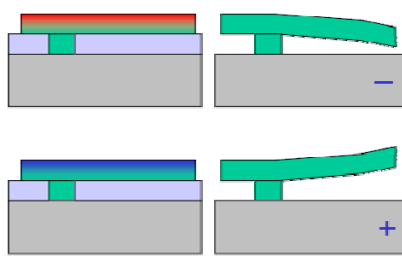
Measurement of Stress Gradient

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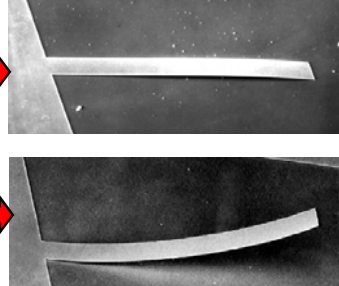
- Use cantilever beams
 - ↳ Strain gradient ($\Gamma = \text{slope of strain-thickness curve}$) causes beams to deflect up or down
 - ↳ Assuming linear strain gradient Γ , $z = \Gamma L^2/2$

■ compressive

■ tensile



[P. Krulevitch Ph.D.]



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Folded-Flexure Suspensions

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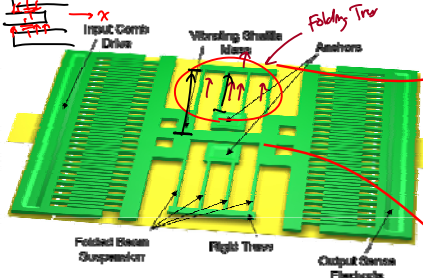
Folded-Flexure Suspensions

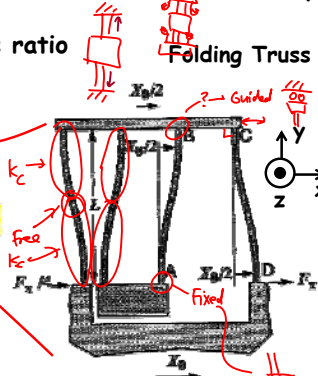
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Folded-Beam Suspension

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- Use of folded-beam suspension brings many benefits
 - ↳ Stress relief: folding truss is free to move in y-direction, so beams can expand and contract more readily to relieve stress
 - ↳ High y-axis to x-axis stiffness ratio





Comb-Driven Folded Beam Actuator

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Beam End Conditions

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TABLE 4.1
Types of commonly used support conditions for beams and frames

Type of support	Displacement boundary conditions	Force boundary conditions
 FREE	None	All, as specified
 PINNED	$u = 0$ $w = 0$	Moment is specified
 ROLLER (vertical)	$u = 0$	Transverse force and moment are specified
 ROLLER (horizontal)	$w = 0$	Horizontal force and bending moment are specified
 FIXED or CLAMPED	$u = 0$ $w = 0$ $dw/dx = 0$	None specified

[From Reddy, Finite Element Method]

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Common Loading & Boundary Conditions

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- Displacement equations derived for various beams with concentrated load F or distributed load f
- Gary Fedder Ph.D. Thesis, EECS, UC Berkeley, 1994

(a) cantilever beam, concentrated load.

(b) guided-end beam, distributed load.

cantilever	guided-end	fixed-fixed
$x = \frac{F_x L}{Eh w}$	$x = \frac{F_x L}{Eh w}$	$x = \frac{F_x L}{4Eh w}$
$y = 4 \frac{F_y L^3}{Eh w^3}$	$y = \frac{F_y L^3}{Eh w^3}$	$y = \frac{1}{16} \frac{F_y L^3}{Eh w^3}$
$z = 4 \frac{F_z L^3}{Eh w^3}$	$z = \frac{F_z L^3}{Eh w^3}$	$z = \frac{1}{16} \frac{F_z L^3}{Eh w^3}$

(a) Concentrated load.

(a) fixed-end beam, concentrated load.

(b) guided-end beam, distributed load.

cantilever	guided-end	fixed-fixed
$x = \frac{f_x L}{E}$	$x = \frac{f_x L}{E}$	$x = \frac{f_x L}{4E}$
$y = \frac{3}{2} \frac{f_y L^4}{Eh w^3}$	$y = \frac{1}{2} \frac{f_y L^4}{Eh w^3}$	$y = \frac{1}{32} \frac{f_y L^4}{Eh w^3}$
$z = \frac{3}{2} \frac{f_z L^4}{Eh w^3}$	$z = \frac{1}{2} \frac{f_z L^4}{Eh w^3}$	$z = \frac{1}{32} \frac{f_z L^4}{Eh w^3}$

(b) Distributed load.

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